

<b>Notice of References Cited</b>	Application/Control No. 10/565,739		Applicant(s)/Patent Under Reexamination TAGAWA ET AL.	
	Examiner VISHAL VASISTH		Art Unit 1797	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,403,503	04-1995	Seiki et al.	508/440
*	B	US-6,228,282	05-2001	Shimomura et al.	252/68
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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